

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)	
)	
ODA et al.)	
)	
Application Number: To be Assigned)	
)	Art Unit 2811
Filed: Concurrently herewith)	
)	
For: SEMICONDUCTOR DEVICE AND)	
MANUFACTURING METHOD)	
)	
Attorney Docket No. HITA.0474)	

Honorable Assistant Commissioner
for Patents
Washington, D.C. 20231

PRELIMINARY AMENDMENT

Sir:

Prior to an examination on the merits, please amend the above identified application as follows: